SUPPLEMENTAL APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Number:: 10/565,2006
Application Date:: 01/24/06
Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?:: NONE

Title:: GAS REACTION SYSTEM AND

SEMICONDUCTOR PROCESSING

APPARATUS

Attorney Docket Number:: 284901US26PCT

Total Drawing Sheets:: 8

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR

Primary Citizenship Country:: Japan

Status:: FULL CAPACITY

Given Name:: Hachishiro
Family Name:: IIZUKA
City of Residence:: Nirasaki-shi
State or Province of Residence:: Yamanashi

Country of Residence:: Japan

Street of Mailing Address:: c/o TOKYO ELECTRON AT LIMITED,

650, Mitsuzawa, Hosaka-cho

City of Mailing Address::

State or Province of Mailing Address::

Country of Mailing Address::

Japan

Postal or Zip Code of Mailing Address:: 407-0192

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/JP04/10895	07/23/04

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2003-279970	Japan	07/25/03	YES

ASSIGNMENT INFORMATION

Assignee Name:: TOKYO ELECTON LIMITED

Street of Mailing Address:: 3-6, Akasaka 5-chome, Minato-ku

City of Mailing Address:: Tokyo
Country of Mailing Address:: Japan
Postal or Zip Code of Mailing Address:: 107-8481